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IC 2800 MAIL ROOM

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:
Masato TAKAHASHI

: GROUP: 2851

SERIAL NUMBER: 09/830,684

: ATTENTION:
Application Division
Customer Corrections

FILED: April 30, 2001

FOR: STAGE DEVICE, EXPOSURE SYSTEM, METHOD OF DEVICE MANUFACTURE,
AND DEVICE

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Assistant Commissioner for Patents
Washington, D.C. 20231

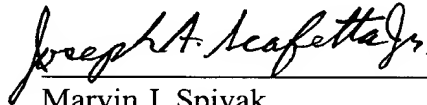
Sir:

The Patent Office is requested to provide a corrected Official Filing Receipt for the attached. If you have any questions, please do not hesitate to contact us.

No fees are required. However, in the event that a fee is required, please charge the appropriate amount to our Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY.DOCKET.NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/830,684	04/30/2001	28	968	206379US2PCT	13	27	3

FC 2800 MAIL ROOM

CONFIRMATION NO. 9633

FILING RECEIPT



OC000000006170348

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Date Mailed: 06/12/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Masato Takashi, Tokyo, JAPAN;

Domestic Priority data as claimed by applicant

THIS APPLICATION IS A 371 OF PCT/JP99/05928 10/27/1999

Foreign Applications

JAPAN 10-306,862 10/28/1998

Projected Publication Date: N/A

Non-Publication Request: No

Early Publication Request: No

Title

Stage device, exposure system, method of device manufacture, and device

Preliminary Class

396

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Page 2 of 3

Data entry by : ORDENEZ, MARTA

Team : OIPE

Date: 06/12/2001

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MASATO TAKAHASHI, TOKYO, JAPAN;